

INFORMATION DISCLOSURE STATEMENT PTO-1449 (PAGE 1 OF 1)				SERIAL NUMBER	DOCKET NO.		
				APPLICANT			
				FILING DATE	GROUP		
U.S. PATENT DOCUMENTS							
EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
FOREIGN PATENT DOCUMENTS					TRANSLATION		
	DOCUMENT NUMBER	DATE	COUNTRY	CLAS	SUBCLASS	YES	NO
RD	JP2001-345183		JAPAN			ABSTRACT	
RD	KR2002-0086950		KOREA			ABSTRACT	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
RD	Korean Office Action dated 15 January 2005 for KR2002-0085904						
RD	Chinese Office Action No. CPCH03635643; dated 4 February 2005 for Patent Application No. 200310121683; corresponds to U.S. Application No. 10/733,636 (current application).						
EXAMINER:	RD		DATE CONSIDERED:		5/25/04		
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP §609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							